

**Response Under 37 C.F.R. §1.116**

**Expedited Procedure**

**Examining Group 1792**

Application No. 10/564,015

Paper Dated: February 10, 2009

In Reply to USPTO Correspondence of December 10, 2008

Attorney Docket No. 0149-053929

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/564,015 Confirmation No. 4101

Applicants : SHINJI SHIMOSAKI ET AL.

Filed : May 12, 2006

Title : METHOD FOR FORMING METAL OXIDE COATING  
FILM AND VAPOR DEPOSITION APPARATUS

Group Art Unit : 1792

Examiner : Francis P. Smith

Customer No. : 28289

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Office Action dated December 10, 2008, Applicants submit the following amendments and remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.

I hereby certify that this correspondence is being electronically submitted to the United States Patent and Trademark Office on February 10, 2009.

02/10/2009

Date

*Florence P. Trevethan*

Signature

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Typed Name of Person Signing Certificate